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TC 1700

1752  
PATENT  
30205/38083

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Geun Su Lee et al.	)	I hereby certify that this paper and the
	)	documents referred to as enclosed
Serial No.: 10/054,532	)	therewith are being deposited with the
	)	United States Postal Service as first class
Filed: January 22, 2002	)	mail, postage prepaid, on December 17,
	)	2003, in an envelope addressed to
For: Photoresist Monomers, Polymers	)	Commissioner for Patents, P.O. Box
Thereof and Photoresist Compositions	)	1450, Alexandria, Virginia 22313-1450
Containing the Same	)	
	)	
Group Art Unit: 1752	)	Michael P. Hull
	)	Reg. No. 35,902
Examiner: Yvette C. Thornton	)	Attorney for Applicants
	)	
	)	

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the office action mailed on September 26, 2003, please amend  
the above-identified patent application as follows: